



**ELECTRONIC COPY**

LG710568449  
Report verification at igi.org



May 28, 2025  
IGI Report Number **LG710568449**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**  
Measurements **10.60 X 7.02 X 4.73 MM**  
**GRADING RESULTS**  
Carat Weight **3.10 CARATS**  
Color Grade **D**  
Clarity Grade **VVS 2**  
Cut Grade **EXCELLENT**

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**GRADING RESULTS**

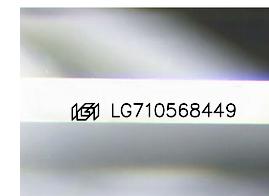
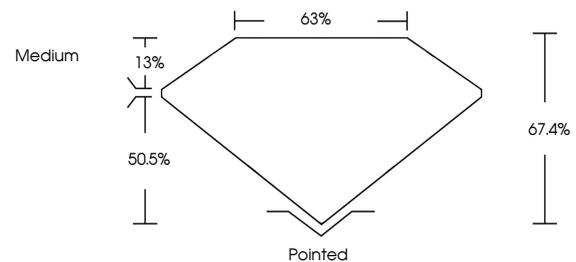
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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG710568449**

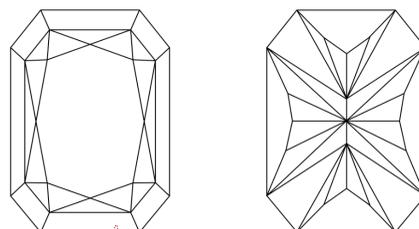
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

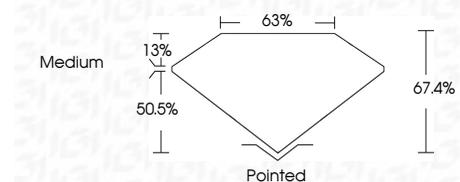
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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CUT CORNERED RECT. MODIFIED BRILLIANT  
10.60 X 7.02 X 4.73 MM  
3.10 CARATS  
D  
EXCELLENT  
67.4%  
63%  
Medium  
Pointed  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG710568449  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa